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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/730,230	12/08/2003	Bishnu P. Gogoi	SC12116ZP	2513	
23125 7	590 11/16/2006		EXAMINER		
	SEMICONDUCTO	ESTRADA, MICHELLE			
LAW DEPART	I MEN I ARMER LANE MD:TX	ART UNIT	PAPER NUMBER		
AUSTIN, TX	78729		2823		
			DATE MAILED: 11/16/2006		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Applicat	ion No.	Applicant(s)				
		10/730,2	230	GOGOI ET AL.				
Office Action Summary			or	Art Unit				
		Michelle		2823				
Period f	The MAILING DATE of this communication Reply	tion appears on th	e cover sheet wi	th the correspondence ac	ddress			
WHIC - Exte after - If NC - Failt Any	ORTENED STATUTORY PERIOD FOR CHEVER IS LONGER, FROM THE MAIL unsions of time may be available under the provisions of 3: SIX (6) MONTHS from the mailing date of this communic or period for reply is specified above, the maximum statutoure to reply within the set or extended period for reply will, reply received by the Office later than three months after the part of the period for reply will, seed patent term adjustment. See 37 CFR 1.704(b).	LING DATE OF T 7 CFR 1.136(a). In no e eation. Try period will apply and v by statute, cause the ap	HIS COMMUNIC vent, however, may a re will expire SIX (6) MON' plication to become AB.	CATION. Poly be timely filed THS from the mailing date of this of the control o				
Status								
1)⊠	Responsive to communication(s) filed of	nn 30 August 200	6					
	•	☐ This action is	_					
3)								
-,	closed in accordance with the practice			•				
Disposit	ion of Claims							
4)⊠	Claim(s) 1-23 is/are pending in the appl	lication.						
	4a) Of the above claim(s) is/are withdrawn from consideration.							
5)⊠	Claim(s) 23 is/are allowed.							
6)⊠	Claim(s) <u>1-22</u> is/are rejected.							
7)⊠								
8)□	Claim(s) are subject to restriction	n and/or election	requirement.					
Applicat	ion Papers							
9)[The specification is objected to by the E	xaminer.						
10)	The drawing(s) filed on is/are: a)	accepted or b)□ objected to t	by the Examiner.				
	Applicant may not request that any objection	n to the drawing(s)	be held in abeyan	ce. See 37 CFR 1.85(a).				
	Replacement drawing sheet(s) including the	e correction is requi	red if the drawing(s) is objected to. See 37 C	FR 1.121(d).			
11)	The oath or declaration is objected to by	the Examiner. N	lote the attached	Office Action or form P	TO-152.			
Priority (under 35 U.S.C. § 119							
•	Acknowledgment is made of a claim for ☐ All b)☐ Some * c)☐ None of:	foreign priority ur	nder 35 U.S.C. §	119(a)-(d) or (f).				
	1. Certified copies of the priority doc	cuments have be	en received.					
	2. Certified copies of the priority doc	cuments have be	en received in A _l	pplication No				
	3. Copies of the certified copies of the	he priority docum	ents have been	received in this National	Stage			
	application from the International	Bureau (PCT Ru	le 17.2(a)).					
* (See the attached detailed Office action for	or a list of the cert	tified copies not i	received.				
Attachmen	t(s)							
	e of References Cited (PTO-892)	•		ummary (PTO-413)				
	e of Draftsperson's Patent Drawing Review (PTO- mation Disclosure Statement(s) (PTO/SB/08)	948))/Mail Date formal Patent Application				
	r No(s)/Mail Date		6) Other:					

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DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1, 2, 4, 9 and 11 are rejected under 35 U.S.C. 102(b) as being anticipated by Razouk et al. (5,911,109).

Re claims 1 and 2, Razouk et al. disclose providing a semiconductor substrate; forming a layer over the semiconductor substrate; forming an opening within the layer; forming (depositing) an insulating layer over the layer at approximately atmospheric pressure that would inherently seal the opening (Col. 1, lines 57-65).

Re claim 4, Razouk et al. disclose wherein forming the insulating layer further comprises depositing the insulating layer and annealing the insulating layer at approximately atmospheric pressure.

Re claim 9, Razouk et al. disclose wherein annealing comprises reflowing the insulating layer.

Re claim 11, Razouk et al. disclose wherein forming an insulating layer comprises forming a phosphosilicate glass (PSG) (Col. 1, lines 55-57).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 3, 5-8 rejected under 35 U.S.C. 103(a) as being unpatentable over Razouk et al. as applied to claims 1, 2, 4, 9 and 11 above, and further in view of the following comments.

Re claim 3, Razouk et al. do not disclose wherein the depositing is performed by CVD.

However, the Examiner takes judicial notice that depositing an insulating layer by CVD is well known in the art at the time of Applicant's invention. It would have been obvious to one of ordinary skill in the art to deposit the insulating layer by CVD to achieve the instant invention.

Re claim 5-8, Razouk et al. do not specifically disclose a type of annealing process.

The Examiner takes judicial notice that furnace anneal, localized anneal, annealing in dopant atmosphere and laser anneal are well known in the art at the time of Applicant's invention. It would have been obvious to one of ordinary skill in the art to use any of these types of anneal to achieve the instant invention. See Sze, "VLSI Technology", pages 355-362.

Allowable Subject Matter

Claim 23 is allowed.

Response to Arguments

Applicant's arguments with respect to claims 1 and 13 have been considered but are most in view of the new ground(s) of rejection.

Applicant argues that Razouk does not teach forming an insulating layer to seat the opening but to prevent voids. However, it is not necessary for the reference to disclose the same advantages as the instant application. It is sufficient that the same materials are treated in the same manner.

Applicant argues that Razouk teaches reflowing the insulating layer to prevent voids not to seal the opening. However, preventing voids is to seal the opening too.

Conclusion

THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of

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the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Michelle Estrada whose telephone number is 571-272-1858. The examiner can normally be reached on Monday through Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew Smith can be reached on 571-272-1907. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 571-272-2800.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Michelle Estrada
Primary Examiner
Art Unit 2823

ME

November 13, 2006